

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DCKET NO. M122-1343		SERIAL NO.	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT Robert Kerr et al.			
					FILING DATE		GROUP	
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Applicable	
PC	AA	5,162,890	11/92	Butler	257	306		
PC	AB	5,166,096	11/92	Cote et al.	437	195		
PC	AC	5,173,752	12/92	Motonami et al.	257	309		
PC	AD	5,272,367	12/93	Dennison et al.	257	306		
PC	AE	5,317,193	05/94	Watanabe	257	774		
PC	AF	5,444,003	08/95	Wang et al.	437	31		
PC	AG	5,510,648	04/96	Davies et al.	257	657		
PC	AH	5,547,892	08/96	Wuu et al.	437	52		
PC	AI	5,552,620	09/96	Lu et al.	257	302		
PC	AJ	5,576,243	11/96	Wuu et al.	437	195		
PC	AK	5,612,240	03/97	Chang	437	44		
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AL							
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
PC	AR		Stanley Wolf, Silicon Processing for the VLSI Era, Volume 3: The Submicron MOSFET, Lattice Press, pg. 136-138, 232-234, 1995					
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EXAMINER PHAT X. CAO				DATE CONSIDERED 4/10/01				
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>								

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MI22-1343

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U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
PC	AA	5,652,174	07/97	Wuu et al.	437	60	
PC	AB	5,668,021	09/97	Subramanian et al.	438	282	
PC	AC	5,710,450	01/98	Chau et al.	257	344	
PC	AD	5,736,441	04/98	Chen	438	255	
PC	AE	5,808,320	09/98	Dennison	257	68	
PC	AF	5,811,350	09/98	Dennison	438	597	
PC	AG	5,885,890	03/99	Dennison	438	597	
PC	AH	5,243,219	09/93	Katayama	287	740	
PC	AI	5,731,610	03/98	Rhodes	257	309	
PC	AJ	5,206,187	04/93	Doan et al.	437	192	
PC	AK	5,763,321	06/98	Ohshima et al.	438	618	

FOREIGN PATENT DOCUMENTS

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PU	AA	5,707,883	01/98	Tabara	437	40	
PU	AB	5,686,331	11/97	Song	437	41	
PU	AC	5,960,318	09/99	Peschke et al.	438	637	
PU	AD	5,747,359	05/98	Yuan et al.	437	186	
PU	AE	5,946,578	08/99	Fujii	438	300	
PU	AF	5,912,492	06/99	Chang et al.	257	344	
PU	AG	5,897,350	04/99	Lee et al.	438	238	
PU	AH	5,891,780	04/99	Hasegawa et al.	438	278	
PU	AI	5,864,155	01/99	Melzner	257	306	
PU	AJ	4,281,448	08/81	Barry et al.	29	577	
PU	AK	5,930,618	07/99	Sun et al.	438	240	

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PC	AA	5,591,662	01/97	Zambrano	437	57	
PU	AB	5,899,712	05/99	Choi et al.	438	163	
PU	AC	4,936,928	06/90	Shaw et al.	148	33.4	
PC	AD	5,970,360	10/99	Cheng et al.	438	398	
PC	AE	5,858,832	01/99	Pan	438	230	
PC	AF	5,866,927	02/99	Cho et al.			
PC	AG	5,827,770	10/98	Rhodes	438	396	
	AH						
	AI						
	AJ						
	AK						

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U.S. PATENT DOCUMENTS

*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
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	AB					
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	AL					

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		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AM							
	AN							
	AO							
	AP							
	AQ							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

pc	AR		Wolf, S., "Silicon Processing for the VLSI Era," Vol. 3: The Submicron MOSFET, Lattice Press 1995, pp. 634-636.
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U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
PC	AA	5,895,269	4/99	Wang et al.	438	675	
PC	AB	6,093,609	7/00	Chuang	438	286	
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						

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							Yes	No
	AM							
	AN							
	AO							
	AP							
	AQ							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

PC	AR		Gray, Paul R. et al., "Analysis and Design of Analog Integrated Circuits," Third Edition, 1993, John Wiley and Sons, page 169 -- specifically the 2 nd paragraph
	AS		
	AT		

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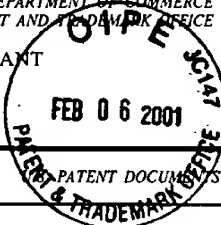
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Micron Technology, Inc.FILING DATE
February 24, 2000GROUP
2825

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
pc	AA	5,874,359	2/23/99	Liaw et al.	438	640	
	AB						
	AC						
	AD						
	AE						
	AF						
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	AH						
	AI						
	AJ						
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Robert Kerr, et al.FILING DATE
February 24, 2000GROUP
2825

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
PC	AA	6,133,103	10/2000	Lee et al.	438	276	
PC	AB	6,097,103	08/2000	Ishigaki	257	903	
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						

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							Yes	No
	AM							
	AN							
	AO							
	AP							
	AO							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

PC	AR		Shenai, K., "A high-density, self-aligned power MOSFET structure fabricated using sacrificial spacer technology" Electron Devices, IEEE Transactions on Electron Devices, Vol. 39, Issue 5, May 1992, pps 1252-1255.
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